



520.42972X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: YODA et al

Serial No.: 10/629,623

Filed: July 30, 2003

For: Multi-Electron Beam Exposure Method And Apparatus

Group: 2881

Examiner: K. Nguyen

**AMENDMENT UNDER 37 CFR 1.312(a)**

Mail Stop: Issue Fee  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 25, 2005

Sir:

The following amendments are respectfully requested in connection  
with the above-identified application:

Amendments to the Claims;

Remarks following the Amendments.